Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	204009	(wafer\$I or semiconductor\$I or chip\$I or substrat\$I or IC or intergrated adj circuit or PCB or printed adj circuit adj board or PWB or printed adj wiring adj board)	USPAT	OR	ON	2005/12/16 13:54
L2	85614	L1 and(correct\$3 or error or inclinat\$3 or skew or slant or tilt\$3 or deviation)	USPAT	OR	ON	2005/12/16 13:41
L3	0	L2 and(turn\$3 or rotat\$3 or moving)with circumferential and(correct\$3 or error)with deviat\$3 and(CCD or camera or sensor\$1 or detector\$1)with serpentine and coordinat\$3	USPAT	OR	ON	2005/12/16 14:09
L4	18	L2 and(turn\$3 or rotat\$3 or moving)and(circumferential or circle)and(correct\$3 or error)with deviat\$3 and(CCD or camera or sensor\$1 or detector\$1)with(serpentine or sprial or circle)and coordinat\$3	USPAT	OR	ON	2005/12/16 13:44
L5	17	L4 and @ad<"20001121"	USPAT	OR	ON	2005/12/16 13:58
L6	683	correct\$3 and bump and block and (plurality or plural\$1)and (wafer\$1 or semiconductor\$1 or chip\$1 or substrat\$1 or IC or intergrated adj circuit or PCB or printed adj circuit adj board or PWB or printed adj wiring adj board)and(inclinat\$3 or shift\$3 or slopes or skew)	USPAT	OR	ON	2005/12/16 13:56
L7	23	L6 and(CCD or camera or sensor\$1 or detector\$1)and scann\$3 near3(serpentine or sprial or circle)	USPAT	OR	ON	2005/12/16 13:58
L8	18	L7 and @ad<"20001121"	USPAT	OR	ON	2005/12/16 13:58
L9	16	L8 and (detect\$3 or determine)and mark\$3	USPAT	OR	ON	2005/12/16 14:04
L10	0	L9 and(turn\$3 or rotat\$3 or moving)with circumferential and(correct\$3 or error)with deviat\$3 and(CCD or camera or sensor\$1 or detector\$1)with(sprial or serpentine or zig adj zag) and coordinat\$3	USPAT	OR	ON	2005/12/16 14:10
L11		L9 and(turn\$3 or rotat\$3 or moving)and(circumferential or circle) and(correct\$3 or error)with deviat\$3 and(CCD or camera or sensor\$1 or detector\$1)with(sprial or serpentine or zig adj zag) and coordinat\$3	USPAT	OR	ON	2005/12/16 14:11

L12	0	L9 and(turn\$3 or rotat\$3 or moving)and(circumferential or circle) and(correct\$3 or error)and deviat\$3 and(CCD or camera or sensor\$1 or detector\$1)and(sprial or serpentine or	USPAT	OR	ON	2005/12/16 14:11
		zig adj zag) and coordinat\$3				

Search History 12/16/05 2:12:06 PM Page 2

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	683	correct\$3 and bump and block and (plurality or plural\$1)and (wafer\$1 or semiconductor\$1 or chip\$1 or substrat\$1 or IC or intergrated adj circuit or PCB or printed adj circuit adj board or PWB or printed adj wiring adj board)and(inclinat\$3 or shift\$3 or slopes or skew)	l (wafer\$l or Sl or substrat\$l circuit or PCB board or PWB		ON	2005/12/16 14:26
L2	21	L1 and(CCD or camera or sensor\$1 or detector\$1)and scann\$3 near3(serpentine or sprial or circle)and(detect\$3 or determine)and mark\$3	al or		ON	2005/12/16 14:20
L3	89327	382/145,151,181,286, "287", "289, 312".ccls.	USPAT	OR	ON	2005/12/16 14:27
L4	73	L3 and L1	USPAT	OR	ON	2005/12/16 14:27
L5	8	L4 and L2	USPAT	OR	ON	2005/12/16 14:28
L6	73	L1 and L3	USPAT	OR	ON	2005/12/16 14:28
L7	8	L2 and L6	USPAT	OR	ON	2005/12/16 14:39
L9·	3701	438/14,460,612,613,614.ccls.	USPAT	OR	ON	2005/12/16 14:40
L10	5	L1 and L9	USPAT	OR	ON	2005/12/16 14:40
L11	0	L10 and L2	USPAT	OR	ON	2005/12/16 14:41
L12	967	257/e23.179.ccls.	USPAT	OR	ON	2005/12/16 14:41
L13	3	L1 and L12	USPAT	OR	ON	2005/12/16 14:41
L14	0	L13 and L2	USPAT	OR	ON	2005/12/16 14:42

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(correct\$3 and bump and block and (plurality or plural\$1)and (wafer\$1 or semiconductor\$1 or chip\$1 or substrat\$1 or IC or intergrated adj circuit or PCB or printed adj circuit adj board or PWB or printed adj wiring adj board)and(inclinat\$3 or shift\$3 or slopes or skew)and(CCD or camera or sensor\$1 or detector\$1)and scann\$3 near3(serpentine or sprial or circle)and(detect\$3 or determine)and mark\$3).clm.	US-PGPUB	OR	ON	2005/12/16 14:46

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			A	dvanced Search:	·
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				limit	

Search history:

No.	Database	Search term	Info added since	Results	
1	INZZ	wafer OR semiconductor OR chip OR substrat OR IC OR intergrated ADJ circuit OR PCB OR printed ADJ circuit ADJ board OR PWB OR printed ADJ wiring ADJ board	unrestricted	691240	show titles
2	INZZ	L1 AND correct* AND bump AND block AND (plurality OR plural*) AND (CCD OR camera OR sensor* OR detector*) AND scann* ADJ (serpentine OR sprial OR circle)	unrestricted	0	-
3	INZZ	L1 AND correct* AND bump AND block AND (plurality OR plural*) AND (inclinat* OR shift* OR slopes OR skew OR deviation)	unrestricted	0	-
4	INZZ	L1 AND correct* AND bump AND (inclinat* OR shift* OR slopes OR skew OR deviation)	unrestricted	0.	-
5	INZZ	L1 AND (CCD OR camera OR sensor OR detector) AND scann* AND (serpentine OR sprial OR circle)	unrestricted	0	-
6	INZZ	L1 AND (CCD OR camera OR sensor OR detector) AND scann*	unrestricted	0	-
7	INZZ	L1 AND (CCD OR camera OR sensor OR detector) AND scanning	unrestricted	1	show titles
8	INZZ	L1 AND L7	unrestricted	2	show titles
9	INZZ	L8 AND (serpentine OR sprial OR circle)	unrestricted	1	show titles

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Information added since: or: none (YYYYMMDD)	<u></u>		search



PALM INTRANET

Day : Friday Date: 12/16/2005

Time: 17:09:29

Inventor Name Search Result

Your Search was:

Last Name = NARITA First Name = SHORIKI

Application#	Patent#	Status	Date Filed	Title	Inventor Name	
08435616	5648729	150	05/05/1995	BOARD POSITIONING METHOD AND APPARATUS OF THE METHODS	NARITA, SHORIKI	
08504654	5769236	150	07/20/1995	COMPONENT COLLECTIVE AND COMPONENT COLLECTIVE FEEDING APPARATUS	NARITA, SHORIKI	
08825499	5955876	150	03/31/1997	BOARD POSITIONING APPARATUS	NARITA, SHORIKI	
09335779	6302317	150	06/18/1999	BUMP BONDING APPARATUS AND METHOD	NARITA, SHORIKI	
09423375	6098868	150	11/04/1999	BUMP FORMING METHOD AND BUMP BONDER	NARITA, SHORIKI	
<u>09690746</u>	6329640	150	10/18/2000	Heating apparatus for bump bonding, bump bonding method and bump forming apparatus, and semiconductor wafer	NARITA, SHORIKI	
<u>09719768</u>	6787391	150	12/18/2000	METHOD OF FORMING BUMPS ON A WAFER UTILIZING A POST-HEATING	NARITA, SHORIKI	
<u>09911801</u>	6494358	150	07/25/2001	BUMP BONDING APPARATUS AND METHOD	NARITA, SHORIKI	
<u>09911802</u>	6568580	150	07/25/2001	BUMP BONDING APPARATUS AND METHOD	NARITA, SHORIKI	
09955110	6392202	150	09/19/2001	HEATING APPARATUS FOR BUMP BONDING, BUMP BONDING METHOD AND BUMP FORMING APPARATUS, AND SEMICONDUCTOR WAFER	NARITA, SHORIKI	
09988704	Not Issued	71		Method and apparatus for correcting inclination of IC on semiconductor wafer	NARITA, SHORIKI	

10019700	6818975	150	01/02/2002	ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE BUMP FORMING DEVICE, METHOD OF REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE DEVICE FOR REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE, AND ELECT	NARITA, SHORIKI
10332026	6910613	150	51	DEVICE AND METHOD FOR FORMING BUMP	NARITA, SHORIKI
10415587	Not Issued	93	04/30/2003	BUMP FORMATION METHOD AND BUMP FORMING APPARATUS TO SEMICONDUCTOR WAFER	NARITA, SHORIKI
10536361	Not Issued	20	05/26/2005	Component-supplying head device, component-supplying device, component-mounting device, and method for moving mounting head portion	NARITA, SHORIKI
10537406	Not Issued	20	06/02/2005	Parts feeder	NARITA, SHORIKI
10651103	Not Issued	94	08/29/2003	BUMP FORMING APPARATUS FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE	NARITA, SHORIKI
10651199	Not Issued	95	08/29/2003		NARITA, SHORIKI

				CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE	
10761412	Not Issued	30		Method of forming bumps on a wafer utilizing a post-heating operation, and an apparatus therefore	NARITA, SHORIKI
11114084	Not Issued	41	04/26/2005	Apparatus and method for forming bump	NARITA, SHORIKI

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Day : Friday Date: 12/16/2005

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Inventor Name Search Result

Your Search was:

Last Name = IKEYA

First Name = MASAHIKO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09423375	6098868	150	11/04/1999	BUMP FORMING METHOD AND BUMP BONDER	IKEYA, MASAHIKO
<u>09719768</u>	<u>6787391</u>	150	12/18/2000	METHOD OF FORMING BUMPS ON A WAFER UTILIZING A POST-HEATING	IKEYA, MASAHIKO
09988704	Not Issued	71	11/20/2001	Method and apparatus for correcting inclination of IC on semiconductor wafer	IKEYA, MASAHIKO
10019700	6818975	150	01/02/2002	ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE BUMP FORMING DEVICE, METHOD OF REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE DEVICE FOR REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE, AND ELECT	IKEYA, MASAHIKO
10234118	Not Issued	93	09/05/2002	COMPONENT MOUNTING APPARATUS AND COMPONENT MOUNTING METHOD	IKEYA, MASAHIKO
10332026	6910613	150	01/02/2003	DEVICE AND METHOD FOR FORMING BUMP	IKEYA, MASAHIKO
10415587	Not Issued	93	04/30/2003	BUMP FORMATION METHOD AND BUMP FORMING APPARATUS TO SEMICONDUCTOR WAFER	IKEYA, MASAHIKO
				SEMICONDUCTOR WAFER	

10651103	Not Issued	94	08/29/2003	BUMP FÖRMING APPARATUS FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE	IKEYA, MASAHIKO
10651199	Not Issued	95	08/29/2003	BUMP FORMING APPARATUS FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE	IKEYA, MASAHIKO
10761412	Not Issued	30	01/22/2004	Method of forming bumps on a wafer utilizing a post-heating operation, and an apparatus therefore	IKEYA, MASAHIKO
11114084	Not Issued	41	04/26/2005	Apparatus and method for forming bump	IKEYA, MASAHIKO

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Inventor Name Search Result

Your Search was:

Last Name = TSUBOI

First Name = YASUTAKA

Application#	Patent#	Status	Date Filed	Title	Inventor Name		
08678658	5825914	150		COMPONENT DETECTION METHOD	TSUBOI, YASUTAKA		
09069203	5872863	150	04/29/1998	COMPONENT DETECTION METHOD	TSUBOI, YASUTAKA		
09622825	6542238	150		ELECTRONIC COMPONENT MOUNTING APPARATUS	TSUBOI, YASUTAKA		
09988704	Not Issued	71	11/20/2001	Method and apparatus for correcting inclination of IC on semiconductor wafer	TSUBOI, YASUTAKA		
10019700	6818975	150	01/02/2002	ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE BUMP FORMING DEVICE, METHOD OF REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE DEVICE FOR REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE, AND ELECT	TSUBOI, YASUTAKA		
10234118	Not Issued	93	09/05/2002	COMPONENT MOUNTING APPARATUS AND COMPONENT MOUNTING METHOD	TSUBOI, YASUTAKA		
10415587	Not Issued	93	04/30/2003	BUMP FORMATION METHOD AND BUMP FORMING APPARATUS TO SEMICONDUCTOR WAFER	TSUBOI, YASUTAKA		
10651103	Not Issued	94	1	BUMP FORMING APPARATUS FOR CHARGE	TSUBOI, YASUTAKA		

				APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, SEMICONDUCTOR SUBSTRATE, SEMICONDUCTOR SUBSTRATE	
10651199	Not Issued	95	08/29/2003	BUMP FORMING APPARATUS FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE	TSUBOI, YASUTAKA

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Day : Friday Date: 12/16/2005

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Inventor Name Search Result

Your Search was:

Last Name = MAE

First Name = TAKAHARU

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Application#		==			Inventor Name
06891028	4763811	150	07/31/1986	PARTS FEEDER	MAE, TAKAHARU
<u>09335779</u>	6302317	150	06/18/1999	BUMP BONDING APPARATUS AND METHOD	MAE, TAKAHARU
<u>09423375</u>	6098868	150	11/04/1999	BUMP FORMING METHOD AND BUMP BONDER	MAE, TAKAHARU
09690746	6329640	150	10/18/2000	Heating apparatus for bump bonding, bump bonding method and bump forming apparatus, and semiconductor wafer	MAE, TAKAHARU
09719768	6787391	150	12/18/2000	METHOD OF FORMING BUMPS ON A WAFER UTILIZING A POST-HEATING	MAE, TAKAHARU
09830508	6619535	150	04/27/2001	WORKING METHOD FOR HOLDING A WORK OBJECT BY SUCTION	MAE, TAKAHARU
<u>09911801</u>	6494358	150	07/25/2001	BUMP BONDING APPARATUS AND METHOD	MAE, TAKAHARU
09911802	6568580	150	07/25/2001	BUMP BONDING APPARATUS AND METHOD	MAE, TAKAHARU
09955110	6392202	150	09/19/2001	HEATING APPARATUS FOR BUMP BONDING, BUMP BONDING METHOD AND BUMP FORMING APPARATUS, AND SEMICONDUCTOR WAFER	MAE, TAKAHARU
09988704	Not Issued	71		Method and apparatus for correcting inclination of IC on semiconductor wafer	MAE, TAKAHARU
10019700	6818975	150	01/02/2002	ELECTRIC CHARGE GENERATING SEMICONDUCTOR	MAE, TAKAHARU

				SUBSTRATE BUMP FORMING DEVICE, METHOD OF REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE DEVICE FOR REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE, AND ELECT	
10324001	Not Issued	41	12/20/2002	Apparatus and method for mounting electronic components	MAE, TAKAHARU
10332026	6910613	150	01/02/2003	DEVICE AND METHOD FOR FORMING BUMP	MAE, TAKAHARU
10415587	Not Issued	93	04/30/2003	BUMP FORMATION METHOD AND BUMP FORMING APPARATUS TO SEMICONDUCTOR WAFER	MAE, TAKAHARU
10508460	Not Issued	20	10/18/2004	Electronic component mounting method and apparatus and ultrasondic bonding head	MAE, TAKAHARU
10651103	Not Issued	94		BUMP FORMING APPARATUS FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE	MAE, TAKAHARU
10651199	Not Issued	95		BUMP FORMING APPARATUS FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE	MAE, TAKAHARU

			REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE	·
10761412	Not Issued	30	Method of forming bumps on a wafer utilizing a post-heating operation, and an apparatus therefore	MAE, TAKAHARU
11114084	Not Issued	41	Apparatus and method for forming bump	MAE, TAKAHARU

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Day : Friday Date: 12/16/2005

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Inventor Name Search Result

Your Search was:

Last Name = KANAYAMA

First Name = SHINJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
08098813	<u>5462626</u>	150		A METHOD OF BONDING AN LEAD AND A TOOL THERFOR	KANAYAMA, SHINJI
08413441	5854745	150	1	METHOD AND APPARATUS FOR MOUNTING ELECTRONIC COMPONENT	KANAYAMA, SHINJI
<u>08496691</u>	5582341	150		BONDING APPARATUS FOR TERMINAL COMPONENT	KANAYAMA, SHINJI
08569937	5894657	150	12/08/1995	MOUNTING APPARATUS FOR ELECTRONIC COMPONENT	KANAYAMA, SHINJI
08589005	5783915	150	01/19/1996	LINEAR ACTUATING APPARATUS	KANAYAMA, SHINJI
09029391	6129203	150		IC DISCARDING APPARATUS FOR FLIP CHIP MOUNTING FACILITY	KANAYAMA, SHINJI
09119974	6017812	150	07/21/1998	BUMP BONDING METHOD AND BUMP BONDING APPARATUS	KANAYAMA, SHINJI
09122901	6467158	150	07/27/1998	COMPONENT FEEDER	KANAYAMA, SHINJI
09155720	6055724	150			KANAYAMA, SHINJI
09254687	6332268	150	03/16/1999	METHOD AND APPARATUS FOR PACKAGING IC CHIP, AND TAPE-SHAPED CARRIER TO BE USED THEREFOR	KANAYAMA, SHINJI
09266928	6264704	150	03/12/1999	METHOD AND APPARATUS FOR MOUNTING COMPONENT	KANAYAMA, SHINJI
09335779	6302317	150	06/18/1999	BUMP BONDING APPARATUS AND METHOD	KANAYAMA, SHINJI

09354087	6321973	150	07/15/1999	BUMP JOINING METHOD	KANAYAMA, SHINJI
09373957	6193136	150	08/13/1999	COMPONENT MOUNTING METHOD AND APPARATUS	KANAYAMA, SHINJI
09388705	Not Issued	161	09/02/1999	COMPONENT MOUNTING TOOL	KANAYAMA, SHINJI
09446031	6647616	150	12/15/1999	BUMP BONDING UNIT WITH TRAY STORAGE AND TRANSPORT APPARATUSES	KANAYAMA, SHINЛ
<u>09690746</u>	6329640	150	10/18/2000	Heating apparatus for bump bonding, bump bonding method and bump forming apparatus, and semiconductor wafer	KANAYAMA, SHINJI
09719768	6787391	150	12/18/2000	METHOD OF FORMING BUMPS ON A WAFER UTILIZING A POST-HEATING	KANAYAMA, SHINJI
09756307	6467670	150	01/08/2001	METHOD AND APPARATUS FOR MOUNTING COMPONENT	KANAYAMA, SHINJI
09763959	6439447	150	02/28/2001	BUMP JOINING JUDGING DEVICE AND METHOD, AND SEMICONDUCTOR COMPONENT PRODUCTION DEVICE AND METHOD	KANAYAMA, SHINJI
09830508	6619535	150	04/27/2001	WORKING METHOD FOR HOLDING A WORK OBJECT BY SUCTION	KANAYAMA, SHINJI
09873347	6506222	150	06/05/2001	METHOD AND APPARATUS FOR MOUNTING COMPONENT	KANAYAMA, SHINJI
<u>09911801</u>	6494358	150	07/25/2001	BUMP BONDING APPARATUS AND METHOD	KANAYAMA, SHINJI
09911802	6568580	150	07/25/2001	BUMP BONDING APPARATUS AND METHOD	KANAYAMA, SHINJI
09955110	6392202	150	09/19/2001	HEATING APPARATUS FOR BUMP BONDING, BUMP BONDING METHOD AND BUMP FORMING APPARATUS, AND SEMICONDUCTOR WAFER	KANAYAMA, SHINJI
09964404	6572005	150	09/28/2001	BUMP JOINING METHOD	KANAYAMA, SHINJI
<u>09988704</u>	Not	71	11/20/2001	Method and apparatus for	KANAYAMA,

10019700 6818975 150 01/02/2002 ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE BUMP FORMING DEVICE, METHOD OF REMOVING ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE DEVICE FOR REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE FROM ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE DEVICE FOR REMOVING ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE, AND ELECT CHARGE GENERATING SEMICONDUCTOR SUBSTRATE, AND ELECT SEMICONDUCTOR SEMICONDUCTOR SUBSTRATE, AND ELECT SEMICONDUCTOR SUBSTRATE, AND ELECT SEMICONDUCTOR SEMICONDUCTOR SEMICONDUCTOR SUBSTRATE, AND ELECT SEMICONDUCTOR SUBSTRATE, AND ELECT SEMICONDUCTOR SUBSTRATE, AND ELECT SEMICONDUCTOR SUBSTRATE, AND ELECT SEMICONDUCTOR SEMICOND		Issued			correcting inclination of IC on semiconductor wafer	SHINЛ
FOR HANDLING ARRAYED SHINJI	10019700	6818975	150	01/02/2002	GENERATING SEMICONDUCTOR SUBSTRATE BUMP FORMING DEVICE, METHOD OF REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR SUBSTRATE DEVICE FOR REMOVING ELECTRIC CHARGE FROM ELECTRIC CHARGE GENERATING SEMICONDUCTOR	
UNLOADER, AND WORKING SHINJI	10069401	6830989	150	02/26/2002	FOR HANDLING ARRAYED	
FRICTIONAL CONNECTION AND HOLDING TOOL USED FOR THE FRICTIONAL CONNECTION DEVICE	10089184	6692214	150	07/17/2002	UNLOADER, AND WORKING	
Issued APPARATUS AND COMPONENT MOUNTING METHOD	10089843	6706130	150	04/04/2002	FRICTIONAL CONNECTION AND HOLDING TOOL USED FOR THE FRICTIONAL	
Issued FOR MOUNTING SHINJI 10332026 6910613 150 01/02/2003 DEVICE AND METHOD FOR KANAYAMA, SHINJI 10375953 Not Issued Shinji O2/28/2003 Component mounting tool, and method and apparatus for mounting component using this tool 10399915 Not Shinji Not Shinji Not Shinji Shinji 10419106 Not 161 04/21/2003 Bump joining method KANAYAMA, Shinji 10419106 Not 161 04/21/2003 Bump joining method KANAYAMA, Shinji 10419106 Not 161 04/21/2003 Bump joining method KANAYAMA, Shinji 10419106 Not 161 O4/21/2003 Bump joining method KANAYAMA, Shinji 10419106 Not 161 O4/21/2003 Bump joining method KANAYAMA, Shinji S	10234118	} I	93	09/05/2002	APPARATUS AND COMPONENT MOUNTING	11 '
FORMING BUMP SHINJI 10375953 Not Issued	10239060	11	94	12/05/2002	FOR MOUNTING	II ' II
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10508460	Not Issued	20	10/18/2004	Electronic component mounting method and apparatus and ultrasondic bonding head	KANAYAMA, SHINJI
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10761412	Not Issued	30	01/22/2004	Method of forming bumps on a wafer utilizing a post-heating operation, and an apparatus therefore	KANAYAMA, SHINJI
10805407	Not Issued	18		Method and apparatus for handling arrayed components	KANAYAMA, SHINJI
11114084	Not Issued	41	04/26/2005	Apparatus and method for forming bump	KANAYAMA, SHINJI
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